

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

US Patent No. 6,903,032

Confirmation no. 9223

Of: Christophe MALEVILLE et al.

Application no. 10/754,930

Issue Date: June 7, 2005

Date Filed: January 8, 2004

For: METHOD FOR PREPARING A  
SEMICONDUCTOR WAFER SURFACE

Attorney Docket No.: 4717-8400

**SUBMISSION UNDER 37 C.F.R. § 1.501**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following references were recently brought to the attention of the patentee during the prosecution of a corresponding foreign application:

U.S. patent nos. 5,374,564 and 7,029,993

The patentee and their attorneys and representatives have reviewed these patents and confirm that they are not material to the patentability of the present claims. Therefore, it is respectfully requested that this letter simply be placed in the file of this patent.

No fee is believed to be due for this response. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

7-18-07  
Date

  
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